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PATENT

IN THE UNITED STATES PATENT, AND TRADEMARK OFFICE

In re Application of: Steven Keetai Park

Serial No.: 09/493,320

Filed: January 28, 2000

For: METHOD OF FABRICATING COPPER-BASED SEMICONDUCTOR DEVICES

USING A SACRIFICIAL DIELECTRIC LAYER AND AN UNCONSTRAINED

COPPER ANNEAL

Group Art Unit: 2825

Examiner: Unknown

Atty. Dkt. No.: 2000.030500/TT3604

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R §§ 1.97(g).(h), this Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

The present Information Disclosure Statement is being filed prior to the receipt of a first Official Action reflecting an examination on the merits, and hence is believed to be timely filed in accordance with 37 C.F.R § 1.97(b). No fees are believed to be due in connection with the filing of this Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these materials, the Assistant Commissioner is hereby authorized to deduct said fees from Advanced Micro Devices, Inc.'s, Deposit Account No. 01-0365/2000.030500/TT3604.

In accordance with 37 C.F.R § 1.97(e)(1), Applicant hereby certifies that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the present statement, as evidenced by the date of the enclosed search report.

Applicant respectfully requests that the listed documents be made of record in the present case.

Respectfully submitted.

Randall C. Furlong, Ph.D. Reg. No. 35,144

Attorney for Applicants

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Date: February 2, 2001

Form PTO-1449 (modified) List of Patents and Publications for Applicant's INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Atty. Docket No. Serial No. 2000.030500 09/493,320		
		Applicant Steven Keetai Park		PT0
		Filing Date: 01/28/00	Group: 2825 2823	11 C
U.S. Patent Documents See Page 1		Patent Documents See Page 1	Other Art See Page 1	310

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
Tu	Αl	5,798,559	08/25/98	Bothra et al.	257	522	09/03/97
Lie	A2	5,559,055	09/24/96	Chang et al.	437	195	12/21/94
	A3						
	A4						
	A5		/				

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
Le	BI	W0 99/09593	02/25/99				Yes
	B2			/			
	B3						
	B4						
	B5						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation				
Lu	CI	International Search Report dated January 23, 2001 (PCT/US00/25679; TT3604-PCT).				
	C2					
	C3					
	C4					
	C5	, ,				
	C6					
	C7					

Examiner:	Kesien	Min	Lu	DATE CONSIDERED:	4/2:	5/63

EXAMINER INITIAL BERFFRENCE CONSIDERD, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP-609, DRAWLENG THROUGH CITATION IS NOT IN CONFORMANCE AND NOT DANIDER D. INCLUDE COPY OF THIS CORMANDER NOT COMMENCED IN COMPUTED AND